IN THE UNITED STATES PATENT AND TRADEMARK OFFICE.

Applicants: Yeo, et al. Docket No.: TSM03-0847

Serial No.: 10/826,602 Art Unit: 1795

Filed: April 16, 2004 Examiner: Raymond, Brittany L.

For: Lithography Apparatus for Manufacture of Integrated Circuits

Mail Stop RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT ACCOMPANYING RCE

Dear Sir

Applicants respectfully submit the following amendments and remarks in response to Examiner's Office Action dated October 2, 2007, which Action is made final, and the subsequent Advisory Action dated December 3, 2007. Applicants respectfully request that these amendments and remarks be entered pursuant to the provisions of 37 CFR § 1.114, and respectfully request reconsideration of the claims.

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